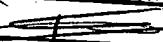




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INFORMATION DISCLOSURE CITATION IN AN APPLICATION Title: MANUFACTURING OF A THIN FILM INORGANIC LIGHT EMITTING DIODE						Attorney Docket No. 27500-73
U.S. PATENT DOCUMENTS						
Examiner Initials	Document Number	Date	Name	Class	Sub- Class	Filing Date If Appropriate
TL	6,129,986	10/10/2000	Bessho et al.	428	421	RECEIVED MAY 20 2002 TECHNOLOGY CENTER 2800
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Examiner Initials	Document Number	Date	Name	Country	Sub- Class	Translation
TL	19812258	9/23/1999	Werner et al.	DE		Abstract
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TL	European Search Report, EP 01 00 0005, June 7, 2001					
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Examiner's Signature: 				Dated: 12/09/02		
Copy of all cited references are enclosed.						